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Docket: 0756-1363

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	IN THE UNITED STATES PATENT	AND TRADEMARK OFFICE	3
In re	PATENT Application of	)	
Hisashi OHTANI et al.		)	
Serial No. 08/479,211		) Art Unit: 1104	
Filed: June 7, 1995		) Examiner: L. Radomsky	
For:	METHOD FOR	)	
	MANUFACTURING	, )	
	SEMICONDUCTOR DEVICE	) Date: February 27, 1997	
	PETITION FOR EXTEN	ISION OF TIME	
Hono	rable Assistant Commissioner for Patents	S	
Wash	ington, D.C. 20231		
Sir:			
I	t is requested that the time to take actio	n in the above matter be extended for	
the tir	me period indicated below:		
	TIME REQUESTED	<u>FEE</u>	
	[ ] 1 month	[ ] \$ 110.00	
	(Small Entity)	[ ] \$ 55.00	
	[X] 2 months	[X] \$ 390.00	-
	(Small Entity)	[ ] \$ 195.00	
	[ ] 3 months	[ ] \$ 930.00	
	(Small Entity)	[ ] \$ 465.00	
	[ ] 4 months	[ ] \$1470.00	
	(Small Entity)	[ ] \$ 735.00	
[X]	The above-noted fee is [X] attached, [	[ ] to be charged to Deposit Account	
	No. 19-2380, under the above order number sc 04/01/97 08479211		
[X]	Document(s) Attached:	1 116 390.00 CK	
	[ ] Response, [ ] Notice of Appea	ıl, [] Brief,	
	[X] Rule 62 Continuation Application,	,	

Docket: 0756-1363

[ ] Other (identify).

[X] The Commissioner is hereby authorized to charge any fees which may be further required in this application, except the issue fee, or credit any overpayment to Deposit Account No. 19-2380, under the above order number. A <u>duplicate</u> of this sheet is attached.

Respectfully submitted,

Jeffrey L. Costellia

Registration No. 35,483

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